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Contents

v Conference Committee

COMPUTATIONAL IMAGING/ONN: JOINT SESSION WITH CONFERENCES 12435 AND 12438

12435 02 Partially coherent neural holography with fast spatial light modulators (Invited Paper) [12435-1]

BIOMEDICAL IMAGING USING A DMD OR OTHER ADVANCED TECHNIQUES I: JOINT SESSION WITH CONFERENCES 12383 AND 12435

- 12435 03 Hyperspectral mid-infrared single-pixel microscopy [12435-4]
- 12435 04 Massively parallel confocal dark field microscopy [12435-5]
- 12435 05 Single-pixel imaging through turbid media by combining a programmable light source and a DMD [12435-6]

BIOMEDICAL IMAGING USING A DMD OR OTHER ADVANCED TECHNIQUES II: JOINT SESSION WITH CONFERENCES 12383 AND 12435

- 12435 06 Hybrid illumination DLP architecture for non-invasive, optical surveillance system of vascular access for hemodialysis patients (Invited Paper) [12435-7]
- 12435 07 Custom incorporation of DMD-based photolithography and photopatterning techniques in soft condensed matter research [12435-8]
- 12435 08 Optimal fitting strategy for modulated illumination localization microscopy [12435-9]

VOLUMETRIC PRINTING AND MASKLESS LITHOGRAPHY: JOINT SESSION WITH CONFERENCES 12433 AND 12435

12435 09 Transient thermal response of DMD (digital micromirror device) with pulsed laser illumination [12435-12]

NOVEL AND ADVANCED APPLICATIONS 12435 0A Compact digital micromirror device (DMD)-based optical architecture for augmented reality (AR) glasses [12435-15] 12435 OB Optical simulation of device efficiency and contrast ratio for a digital micromirror device [12435-16] 12435 OC Dynamic three-dimensional imaging with cubic-meter-level measurement volume using multiscale band-limited illumination profilometry (Best Student Paper Award) [12435-17] Wide field of view real-time flash DMD-lidar with 2D multi-pixel photon counter [12435-18] 12435 0D **SESSION 7** TI PLM 12435 OE Beam tracking and image steering by Texas Instruments phase light modulator based on camera input for lidar and AR applications [12435-20]

12435 OF Enhancement of image quality utilizing time multiplexing phase only holograms (Best Paper Award) [12435-21]

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